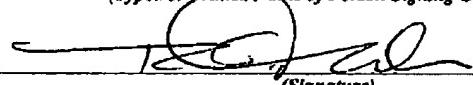


DEC 19 2005

TRANSMITTAL LETTER (General Patent Pending)		Docket No. 16627-US-DIV	
In Re Application Of: Rabah BOUKHERROUB, et al.			
Serial No.	Filing Date	Examiner.	Group Art Unit
10/830,035	23 April 2004	dahimene, m.	1765
Title: PASSIVATION OF POROUS SEMICONDUCTORS			
<b><u>TO THE ASSISTANT COMMISSIONER FOR PATENTS:</u></b>			
Transmitted herewith is:			
Response to the Restriction Requirement Mailed 10/17/2005 Petition for extension of time under 37 CFR 1.136(a) in duplicate Certificate of Transmission By Facsimile (2)			
In the above identified application.			
<input type="checkbox"/> No additional fee is required. <input type="checkbox"/> A check in the Amount of _____ is attached. <input checked="" type="checkbox"/> The assistant Commissioner is hereby authorized to charge and credit Deposit Account No. 13-1717 as described below. A duplicate copy of this sheet is enclosed.			
<input checked="" type="checkbox"/> Charge the amount of \$120.00 <input type="checkbox"/> Credit any overpayment. <input checked="" type="checkbox"/> Charge any additional fee required.			
 <i>Signature</i>		Dated: 19 December 2005	
Richard J. Mitchell 34,519		I certify that this document and fee being deposited on _____ with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.	
Marks & Clerk Canada P.O. Box 957 Station B Ottawa, ON, K1P 5S7 Phone: (613) 236-9561		 * 2 3 5 5 3 *	
<b><i>Signature of Person Mailing Correspondence</i></b>			
<b><i>Typed or Printed Name of Person Mailing Correspondence</i></b>			

<b>CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8)</b>		Docket No. 16627-US-DIV
Applicant(s): Rabah BOUKHERROUB, et al.		
Serial No. 10/830,035	Filing Date 23 April 2004	Examiner DAHIMENE, M.
Invention: PASSIVATION OF POROUS SEMICONDUCTORS		
<p>I hereby certify that this <u>RESPONSE TO THE RESTRICTION REQUIREMENT MAILED 10/17/2005</u> <small>(Identify type of correspondence)</small></p> <p>is being facsimile transmitted to the United States Patent and Trademarks Office (Fax. No. <u>1-571-273-8300</u>)</p> <p>on <u>19 December 2005</u> <small>(Date)</small></p> <p style="text-align: center;"><b>PAT MARTIN</b> <small>(Typed or Printed Name of Person Signing Certificate)</small></p>  <p><small>(Signature)</small></p> <p><small>Note: Each paper must have its own certification of mailing.</small></p>		

CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8)		Docket No. 16627-US-DIV
Applicant(s): Rabah BOUKHERROUB, et al.		
Serial No. 10/830,035	Filing Date 23 April 2004	Examiner DAHIMENE, M.
Invention: PASSIVATION OF POROUS SEMICONDUCTORS		
<p>I hereby certify that this <u>PETITION FOR EXTENSION OF TIME UNDER 37 CFR 1.136 (a)</u> in duplicate <i>(Identify type of correspondence)</i> is being facsimile transmitted to the United States Patent and Trademarks Office (Fax. No. <u>1-571-273-8300</u>) on <u>19 December 2005</u> <i>(Date)</i></p> <p style="text-align: center;"><b>PAT MARTIN</b> <i>(Typed or Printed Name of Person Signing Certificate)</i></p>  <p style="text-align: center;"><i>(Signature)</i></p> <p><b>Note:</b> Each paper must have its own certification of mailing.</p>		

P18/REV01